

DOCKET NO: 293163US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
NOBUAKI MATSUOKA, ET AL. : EXAMINER: HORNING, J. G.
SERIAL NO: 10/585,975 :
FILED: JULY 13, 2006 : GROUP ART UNIT: 1792
FOR: SUBSTRATE PROCESSING :
APPARATUS AND SUBSTRATE
PROCESSING METHOD

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement dated June 5, 2009, Applicants hereby elect, *without traverse*, Group I, claims 18-28, drawn to a substrate processing apparatus. Applicants make this election based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Accordingly, examination on the merits of Group I, claims 18-28 is believed to be in order and an early and favorable action is respectfully requested.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
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